Search No	otes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/754,542	KIMURA, HAJIME	
Examiner	Art Unit	
Dalei Dong	2879	

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Class	Subclass	Date	Examiner
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INI	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
,			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
313/504-512 (text search only - see seach history print out)	8/30/2005	D.D. \$
consulted with Mariceli Santiago regarding the uneven surface of the cathode	8/30/2005	D.D.
examined the Divisional Application for Double Patenting	8/30/2005	D.D.